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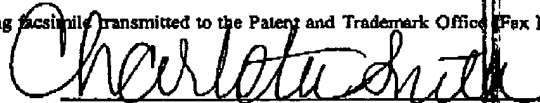
Docket No. 74019-1041

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Takeshi YAMASHITA et al. ) Group Art Unit: 1765  
Serial No. 10/759,180 ) Examiner: Not Yet Assigned  
Filed: January 20, 2004 ) Confirmation No.: 7694  
For: *DRY ETCHING METHOD,  
FABRICATION METHOD FOR  
SEMICONDUCTOR DEVICE, AND DRY  
ETCHING APPARATUS*

## Certificate of Transmission

I hereby certify that this correspondence is being facsimile transmitted to the Patent and Trademark Office (Fax No. (703)872-9306) on May 7, 2005.

  
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## STATUS INQUIRY

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please advise, in writing, as to the current status of the above-identified application.

Respectfully submitted,



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